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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
Shinji UCHIDA Application No.: 10/693,104 Filed: October 27, 2003	:	Examiner: D. D. Le
)	
	:	Group Art Unit: 2834
	:	Confirmation No.: 1628
)	
	:	
For: POSITIONING APPARATUS AND)	February 14, 2005
CHARGED-PARTICLE-BEAM EXPOSURE	. :	(Monday)
APPARATUS)	
Mail Stop Amendment		
Commissioner for Patents		

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated November 12, 2004, please amend the aboveidentified application as follows: